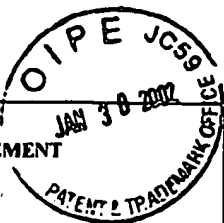


FORM 1449*

INFORMATION DISCLOSURE STATEMENT

IN AN APPLICATION

(Use several sheets if necessary)



Docket Number:

50019.0077 US 01

Application Number:

09/932,061

Applicant: Douglas Michael Hannan and Roy L. Harbrough

Filing Date: August 17, 2001

Group Art Unit: 2053816

RECEIVED
FEB 05 2002

Technology Center 2600

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
HEN	US 6,252,435 B1	06/26/2001	Wu et al.	327	65	10/05/2000

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

HEN	National Semiconductor Corporation, Syed B. Huq/John Goldie, "An Overview of LVDS Technology," July 1998 (6 pages)
HEN	National Semiconductor Corporation, "LVDS Owner's Manual, Introduction to LVDS," 2000 (16 pages)
HEN	"IEEE Standard Dictionary of Electrical and Electronic Terms," 6 th Edition 1996, page 388, "fail-safe circuit" (1 page)
HEN	Texas Instruments, "Low Voltage Differential Signaling (LVDS) Technology: The Basics," 2000 (3 pages)
HEN	Texas Instruments, "Industry's First LVDS Dual Driver/Receiver Devices Extend Reach of New Data Interface Standard," 2000 (4 pages)



23552

PATENT TRADEMARK OFFICE

EXAMINER

HAI L. NGUYEN

DATE CONSIDERED

11/26/2004

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.